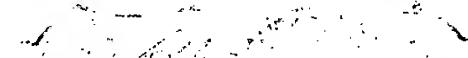


		Subclass
	Class	
ISSUE C		



**PATENT NUMBER**

**U.S. UTILITY Patent Application**

COT O.I.P.E.

**PATENT DATE**

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APPLICATION NO.	CONT/PRIORS	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/783377	D	184	437	17442	Marillo Alessandro

APPLICANTS  
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Methods of forming aluminum-comprising physical vapor deposition targets; sputtered films; and target constructions

PTO-2040  
12/99

**ISSUING CLASSIFICATION**

TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	(Assistant Examiner) _____ (Date) _____			NOTICE OF ALLOWANCE MAILED	
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S. Patent. No. _____ _____ _____	(Primary Examiner) _____ (Date) _____				
<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.	(Legal Instruments Examiner) _____ (Date) _____			ISSUE FEE	
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